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** CONTINUING DATA *****

no none

** FOREIGN APPLICATIONS *****

JAPAN 2002-221929 07/30/2002

no none

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35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>Wile</i>	Initials		

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TITLE

Ion beam apparatus, ion beam processing method and sample holder member

FILING FEE

FEES: Authority has been given in Paper
 No. _____ to charge/credit DEPOSIT ACCOUNT

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)
<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)